

Form PTO-7140 <div style="border: 2px solid black; border-radius: 50%; padding: 10px; display: inline-block; transform: rotate(-15deg);"> OIP E JC12 JUN 22 2005 PATENT & TRADEMARK OFFICE </div>		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1284		SERIAL NO. 09/421,625	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Eugene P. Marsh			
				FILING DATE October 19, 1999		GROUP 2811	

U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA						
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FOREIGN PATENT DOCUMENTS							
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					Yes	No	
AM							
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
<div style="border: 1px solid black; padding: 2px; display: inline-block;"> V_m </div>	AR		Toru Nasu, et al, Study of Pt Bottom Electrodes Using High-Temperature Sputtering for Ferroelectric Memories with SrBi2Ta2O9 (SBTO) Film, Jpn. J. Appl. Phys. Vol. 37 (1998) pp. 4144-4148.
	AS		

EXAMINER HUNG VU	DATE CONSIDERED 02/21/06
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.